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TRANSMITTAL OF INFORMATION DISCLOSURE STATEMENT (Under 37 CFR 1.97(b) or 1.97(c))			Docket No. WLJ.075	
In Re Application Of: John MacNeil				
MAR 29 2002				
Serial No. 09/914,204	Filing Date 08/23/2001	Examiner UNKNOWN	Group Art Unit UNKNOWN	
Title: A METHOD OF PROCESSING A POLYMER LAYER			RECEIVED JUL 05 2002 TC 1700	
<p>Address to: Assistant Commissioner for Patents Washington, D.C. 20231</p> <p>37 CFR 1.97(b)</p> <p>1. <input checked="" type="checkbox"/> The Information Disclosure Statement submitted herewith is being filed within three months of the filing of a national application other than a continued prosecution application under 37 CFR 1.53(d); within three months of the date of entry of the national stage as set forth in 37 CFR 1.491 in an international application; before the mailing of a first Office Action on the merits, or before the mailing of a first Office Action after the filing of a request for continued examination under 37 CFR 1.114.</p> <p>37 CFR 1.97(c)</p> <p>2. <input type="checkbox"/> The Information Disclosure Statement submitted herewith is being filed after the period specified in 37 CFR 1.97(b), provided that the Information Disclosure Statement is filed before the mailing date of a Final Action under 37 CFR 1.113, a Notice of Allowance under 37 CFR 1.311, or an Action that otherwise closes prosecution in the application, and is accompanied by one of:</p> <p><input type="checkbox"/> the statement specified in 37 CFR 1.97(e);</p> <p>OR</p> <p><input type="checkbox"/> the fee set forth in 37 CFR 1.17(p).</p> <p>3. <input checked="" type="checkbox"/> The Examiner's attention is also directed to the following related applications:</p> <p>(1) Serial No. 09/763,641, filed February 26, 2001, and entitled "Method And Apparatus For Forming A Film On A Substrate"</p> <p>(2) Serial No. 09/942,933, filed August 31, 2001, and entitled "Dielectric Layer For A Semiconductor Device And Method Of Producing The Same"</p>				

**TRANSMITTAL OF INFORMATION DISCLOSURE STATEMENT**

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(Only complete if Applicant elects to pay the fee set forth in 37 CFR 1.17(p))

- ☐ A check in the amount of \_\_\_\_\_ is attached.
- ☐ The Assistant Commissioner is hereby authorized to charge and credit Deposit Account No. \_\_\_\_\_ as described below. A duplicate copy of this sheet is enclosed.
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Signature

Dated: MARCH 29, 2002

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<b>INFORMATION DISCLOSURE CITATION</b> <i>(Use several sheets if necessary)</i>				ATTY DOCKET NO. <b>WLJ.075</b>		SERIAL NO. <b>09/914,204</b>	
				John MacNeil FILING <b>08/23/2001</b>		GROUP <b>UNKNOWN</b>	

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U.S. PATENT DOCUMENTS							
*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	A	3,223,040	12/14/1965	DINKELKAMP			
	B	4,793,524	12/27/1988	STARR			
	C	5,095,938	03/17/1992	GARRISON			
	D	5,098,741	03/24/1992	NOLET ET AL.			
	E	5,195,655	03/23/1993	BUKHMAN			
	F	5,273,851	12/28/1993	TAKEI ET AL.			
	G	5,314,724	05/24/1994	TSUKUNE ET AL.			
	H	5,356,034	10/18/1994	SCHLUMBERGER			
	I	5,494,712	02/27/1996	HU ET AL.			
	J	5,534,069	07/09/1996	KUWABARA ET AL.			
	K	5,593,741	01/14/1997	IKEDA			

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FOREIGN PATENT DOCUMENTS								
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
							YES	NO
	L	GB 2 280 169 A	01/25/1995	UNITED KINGDOM			✓	
	M	GB 2 220 869 A	01/24/1990	UNITED KINGDOM			✓	
	N	GB 2 111 064 A	06/29/1983	UNITED KINGDOM			✓	
	O	GB 2 108 133 A	05/11/1983	UNITED KINGDOM			✓	
	P	EP 0 529 334 A2	03/03/1993	EPO			✓	

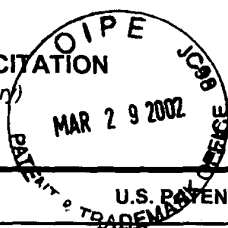
OTHER DOCUMENTS <i>(Including Author, Title, Date, Pertinent Pages, Etc.)</i>			
		Q	Kamiya Kazuo, "Production of Silicon Dioxide Coating," Patent Abstracts of Japan, Publication No. 10310866, Publication Date 24-11-98
		R	A. Grill et al, "Low dielectric constant films prepared by plasma-enhanced chemical vapor deposition from tetramethylsilane," Journal of Applied Physics, Volume 85, Number 6, 15 March 1999, pages 3314-3318.

EXAMINER	DATE CONSIDERED
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\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

# INFORMATION DISCLOSURE CITATION

(Use several sheets if necessary)



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John MacNeil

FILING

08/23/2001

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## U.S. PATENT DOCUMENTS

*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
S		5,876,503	03/02/1999	ROEDER ET AL.			
T		5,620,524	04/15/1997	FAN ET AL.			
U		5,641,559	06/24/1997	NAMIKI			
V		5,730,804	03/24/1998	GOMI ET AL.			
W		5,786,039	07/28/1998	BROUQUET			

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## FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
							YES	NO
X		EP 0 254 205 A2	01/27/1998	EPO				✓
Y		EP 0 726 599 A2	08/14/1996	EPO			✓	
Z		EP 0 212 691	03/04/1987	EPO			✓	
AA		EP 0 826 791 A2	03/04/1998	EPO			✓	
BB		WO 98/23787	06/05/1998	EPO			✓	

## OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)


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